S	earch	Notes	

Application/Control No.	Applicant(s)/Patent under Reexamination
10/664,878	TAKESHIMA ET AL.
Examiner	Art Unit
Jin-Cheng Wang	2628

SEARCHED				
Class	Subclass	Date	Examiner	
345	629	7/7/2006	JCW	
		:		

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
345	629	7/7/2006	JCM
		-	
Word search report attached		7/7/2006	JCW

SEARCH N (INCLUDING SEARC		)
	DATE	EXMR
EAST	7/7/2006	JCW
Word search report attached	7/7/2006	JCW